

FW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Taiji EMA et al.**

Art Unit: **1765**

Application Number: **10/797,188**

Examiner: **Lynette T. Umez Eronini**

Filed: **March 11, 2004**

Confirmation Number: **4959**

For: **METHOD FOR FABRICATING SEMICONDUCTOR STORAGE DEVICE**



Attorney Docket Number: **960045E**
Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.97(c)(1)/(e)(1)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

May 8, 2008

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO/SB/08. A copy of each non - U.S. document is attached.

This Information Disclosure Statement (IDS) is being submitted after issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry of the national stage for the above-captioned application, but prior to issuance of either a final official action or a Notice of Allowance.

The undersigned hereby certifies that each item of information contained in the IDS was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the IDS. A copy of the foreign communication citing the documents is attached.

Application No.: 10/797,188
Art Unit: 1765

Information Disclosure Statement under 1.97(c)(1)
Attorney Docket No.: 960045E

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP



Stephen G. Adrian
Attorney for Applicants
Registration No. 32,878
Telephone: (202) 822-1100
Facsimile: (202) 822-1111

SGA/mra

Enclosures: PTO/SB/08
3 Documents